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CONFIRMATION NO. 4653

<b>SERIAL NUMBER</b> 10/628,601	<b>FILING OR 371(c) DATE</b> 07/28/2003 <b>RULE</b>	<b>CLASS</b> 438	<b>GROUP ART UNIT</b> 2812	<b>ATTORNEY DOCKET NO.</b> 31692-73091
<b>APPLICANTS</b> Michael J. Berman, Portland, OR; George E. Bailey, Welches, OR; Rennie G. Barber, Gresham, OR;				
<b>** CONTINUING DATA *****</b> This application is a DIV of 10/138,742.05/03/2002 PAT 6,627,466				
<b>** FOREIGN APPLICATIONS *****</b>				
<b>IF REQUIRED, FOREIGN FILING LICENSE GRANTED</b> <b>** 01/06/2004</b>				
Foreign Priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Allowance Verified and Acknowledged <u>Examiner's Signature</u> <u>Initials</u>		<b>STATE OR COUNTRY</b> OR	<b>SHEETS DRAWING</b> 2	<b>TOTAL CLAIMS</b> 7
				<b>INDEPENDENT CLAIMS</b> 1
<b>ADDRESS</b> LSI LOGIC CORPORATION PATENT LAW DEPARTMENT 1621 BARBER LANE MS: D-106 MILPITAS , CA 95035				
<b>TITLE</b> METHOD AND APPARATUS FOR DETECTING BACKSIDE CONTAMINATION DURING FABRICATION OF A SEMICONDUCTOR WAFER				
<b>FILING FEE RECEIVED</b> 1050	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	